

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/565,394	KOBAYASHI ET AL.	
Examiner	Art Unit	
Hau V. Phan	3618	

SEARCHED				
Class	Subclass	Date	Examiner	
180	89.2 309	2/19/2008	HP	
	296			
	219			
181	250	2/19/2008	HP	
	207			
	273			
	227			
60	322	2/19/2008	HP	
	299			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		